

2813
PATENT

Case Docket No. ASMMC.036AUS

Date: July 21, 2003

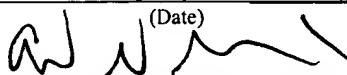
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Sophie et al.
App. No. : 09/975,466
Filed : October 9, 2001
For : IN SITU REDUCTION OF
COPPER OXIDE PRIOR TO
SILICON CARBIDE
DEPOSITION
Examiner : Kielin
Group Art Unit : 2813

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 21, 2003

(Date)


Andrew N. Merickel, Reg. No. 53,317

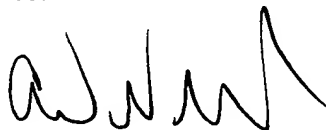
TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with 1 reference.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.



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